

INTERNATIONAL SEARCH REPORT

International Application No

PCT/GB2004/005048

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G03F7/20

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 G03F

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, IBM-TDB, PAJ, INSPEC

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y	US 2003/138731 A1 (FANG TRELIANT) 24 July 2003 (2003-07-24) paragraph '0035!; claims 1,2 -----	1-18
Y	ZHONG-GENG LING; KUN LIAN; LINKE JIAN: "Improved patterning quality of SU-8 microstructures by optimizing the exposure parameters" PROC. OF SPIE; ADVANCES IN RESIST TECHNOLOGY AND PROCESSING XVII, vol. 3999, 2000, pages 1019-1027, XP002322396 cited in the application Paragraph 4.2; figures 5,6,10 ----- -/--	1-18



Further documents are listed in the continuation of box C.



Patent family members are listed in annex.

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Date of the actual completion of the international search

24 March 2005

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08/04/2005

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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

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A	US 2002/115016 A1 (WARREN JOHN B) 22 August 2002 (2002-08-22) paragraphs '0019!, '0020!, '0024! - '0026! -----	1-18
A	CONRADIE E H ET AL: "SU-8 thick photoresist processing as a functional material for MEMS applications" JOURNAL OF MICROMECHANICS & MICROENGINEERING, NEW YORK, NY, US, vol. 12, no. 4, 2002, pages 368-374, XP002266218 ISSN: 0960-1317 abstract -----	1-18
A	EP 0 385 122 A (INTERNATIONAL BUSINESS MACHINES CORPORATION) 5 September 1990 (1990-09-05) page 2, lines 42-48 page 5, lines 3-14; claim 1 -----	1-18
A	US 2002/006588 A1 (AFROMOWITZ MARTIN A) 17 January 2002 (2002-01-17) abstract; claims 1,17 -----	1-18
A	US 4 882 245 A (GELORME ET AL) 21 November 1989 (1989-11-21) cited in the application the whole document -----	1-18

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